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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Terry L. Gilton and Li Li

Art Unit: 2814

COPY

Application No.: 09/579,345

Filed: May 25, 2000

For: SEMICONDUCTOR FABRICATION
METHODS AND APPARATUS

Examiner: S. Rao

Date: June 19, 2002

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service on June 19, 2002 as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, WASHINGTON D.C. 20231.

Attorney for Applicant

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REQUEST FOR STATUS OF APPLICATION

COMMISSIONER FOR PATENTS
Washington, DC 20231

A final office action for the above-referenced patent application was mailed on October 10, 2001. In a telephone conference with applicant's attorney on January 8, 2002, Examiner Rao indicated that applicants' written Request for Interview, dated November 1, 2001, was fully responsive to the Final Office action and no further submission by applicants was necessary. Examiner Rao also indicated that he would issue another Office action in response to applicants' Request for Interview. However, applicants' attorney has not received further action concerning the examination of this application.

A status report regarding the above-referenced application is respectfully requested.

Respectfully submitted,

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